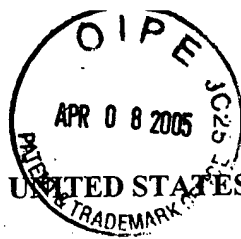


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 40296-0041

Applicant: Yu Chang KIM et al.

Confirmation No.:

Appl. No.: Unassigned

Examiner: Unassigned

Filing Date: December 8, 2003

Art Unit: Unassigned

Title: METHOD FOR MANUFACTURING METAL LINE OF
SEMICONDUCTOR DEVICE

CLAIM FOR CONVENTION PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. § 119 is hereby claimed. In support of this claim, filed herewith is a certified copy of said original foreign application:

Korean Patent Application No. 10-2003-0034843 filed May 30, 2003

Respectfully submitted,

Date: December 8, 2003

By

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KOREAN INTELLECTUAL
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별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원 번호 : 10-2003-0034843
Application Number

출원 년 월 일 : 2003년 05월 30일
Date of Application MAY 30, 2003

출원인 : 주식회사 하이닉스반도체
Applicant(s) Hynix Semiconductor Inc.



2003 년 10 월 06 일

특 허 청

COMMISSIONER

